

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/699,897 ✓  
Filing Date ..... October 27, 2000  
Inventor ..... Mathew S. Cooper  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1753  
Examiner ..... R. McDonald  
Attorney's Docket No. .... H0001190 (4016)  
Title: Physical Vapor Deposition Components and Methods of Formation

1251 12/C  
AS  
7/25/3

**RESPONSE TO MAY 22, 2003 NOTICE OF NON-COMPLIANT AMENDMENT**

To: Art Unit 1753  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
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**AMENDMENTS****Introductory Comments**

The present Response is submitted in the Revised Amendment Format and  
therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

07/25/2003 ASINGLET 00000002 230925 09699897  
01 FC:1251 110.00 DA

Adjustment date: 08/12/2003 EEKUBAY1  
07/25/2003 ASINGLET 00000002 230925 09699897  
01 FC:1251 110.00 CR